On A MEMS-Based Parametrically Amplified Atomic Force Sensor



Outline

- Parametric amplifier theory Manley-Rowe power equations
- Test environment

Equipment MEMS process

Parametric Amplifier experiment
 MEMS design

Results

AFM Experiment

MEMS design Results

- Combined Experiment
 Results
- Conclusion

Parametric Amplification Motivation

On-chip preamplification of signals

- •Amplifier integrated with sensor
- •Reduce effect of parasitic capacitance
- •No transistors
- •No need to integrate VLSI with MEMS
- •Low noise gain
- Upconvert to a higher frequency

Parametric Amplification Premise

To use nonlinear mixing to raise small, low frequency signals above the noise floor

- Using a characterized nonlinear component in an otherwise linear system, we can convolve a small amplitude, low frequency signal (signal) with a high frequency, high amplitude signal ("carrier" or "pump")
- This is a subset of a phenomenon known as 'mixing', wherein the convolution of two signals produces the set of all of the harmonics.
- If, at the output, we filter all but one of the harmonics, then we can demodulate this signal to restore the initial input.

Parametric Amplification

If certain criteria are met, then the system will function as a *parametric amplifier*.

These conditions are:

- Single-valued, lossless, non-linear device
- Weak coupling between modes in non-linear device
- Perfect filters (i.e. non-resonant frequencies see an open circuit)
- Circuit layout as such:



If these conditions hold, then the Manley-Rowe equations reduce to:

$$rac{P_{0,1}}{f_{0,1}}+rac{P_{1,1}}{f_{1,1}}=0 \quad ext{and} \quad rac{P_{1,0}}{f_{1,0}}+rac{P_{1,1}}{f_{1,1}}=0$$

where gain (P $_{1,1}$ /P $_{1,0}$) depends only on the ratio of frequencies

Amplitude Modulation

Given arbitrary modulating signal, f(t), and a carrier, $\cos(\omega_0 t)$, we convolve to get the modulated signal: $f(t) \Leftrightarrow F(\omega)$

 $g(t) = \cos(\omega_0 t) = \frac{1}{2} \left(e^{j\omega_0 t} + e^{j\omega_0 t} \right) \Leftrightarrow G(\omega) = \pi \left[\delta(\omega - \omega_0) + \delta(\omega + \omega_0) \right]$ $f(t) \cos(\omega_0 t) \Leftrightarrow F(\omega) * G(\omega) = \frac{\pi}{2} \left[F(\omega - \omega_0) + F(\omega + \omega_0) \right]$



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The System Being Tested



Using only one function generator, we can find the frequency response characteristics of the resonator system:



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Operation as a Mixer

According to the previous schematic, the force applied to the resonator (and thus the displacement) is proportional to the input voltage squared.

If we have two sine waves in V, this leads to: $F \propto \left(\left(V_{a0} + V_a \sin(\omega_a t) \right) + \left(V_{b0} + V_b \sin(\omega_b t) \right) \right)^2 \qquad V_{c0} = V_{a0} + V_{b0}$ $F \propto V_{c0}^{2} + 2V_{c0}V_a \sin(\omega_a t) + 2V_{c0}V_a \sin(\omega_a t) + 2V_a \sin(\omega_a t)V_b \sin(\omega_b t) + \dots$ $\left(V_a \sin(\omega_a t) \right)^2 + \left(V_b \sin(\omega_b t) \right)^2$

Recall, multiplication in time domain is equivalent to convolution in frequency domain.



Manley-Rowe Power Equations

Assumptions/Terminology:

- Non-linear capacitor, no hysteresis, voltage is a single-valued function of q, v(q)
- $f_{m,n} = mf_1 + nf_2$

•
$$q(t) = \sum_{m=-\infty}^{\infty} \sum_{n=-\infty}^{\infty} Q_{m,n} \exp[j(m\omega_1 t + n\omega_2 t)]$$

• For Real q,



Manley-Rowe Power Equations

$$i = \frac{dq}{dt} = \sum_{m=-\infty}^{\infty} \sum_{n=-\infty}^{\infty} j(m\omega_1 t + n\omega_2 t) Q_{m,n} \exp[j(m\omega_1 t + n\omega_2 t)]$$

$$V = \sum_{m=-\infty} \sum_{n=-\infty} V_{m,n} \exp[j(m\omega_1 t + n\omega_2 t)]$$

Find Fourier coefficients:

$$V_{m,n} = \frac{1}{4\pi^2} \int_{0}^{2\pi} \int_{0}^{2\pi} v(q) \exp\left[-j\left(m\omega_1 t + n\omega_2 t\right)\right] d(\omega_1 t) d(\omega_2 t)$$
$$I_{m,n} = j\left(m\omega_1 t + n\omega_2 t\right) Q_{m,n}$$

Multiply $jmQ_{m,n}^*$ and $V_{m,n}$ and sum over all m,n to find power: $Power = 2\Re(VI^*)$ $\sum_{m=-\infty}^{\infty}\sum_{n=-\infty}^{\infty}\frac{mV_{m,n}I_{m,n}^*}{mf_1 + nf_2} = \frac{1}{2\pi}\int_{0}^{2\pi}\int_{0}^{2\pi}v\frac{\partial q}{\partial \omega_1 t} d(\omega_1 t)d(\omega_2 t)$

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Manley-Rowe Power Equations

Since q is single-valued and 2 π periodic in $\omega_1 t$ and $\omega_2 t$, the RHS of the previous equation equals zero.

This gives us the Manley-Rowe Power Relation for ω_1 :

 $\sum_{m=0}^{\infty}\sum_{n=-\infty}^{\infty}\frac{mP_{m,n}}{mf_1+nf_2}=0$

Similarly if we follow through with ω_2 , then we get:

$$\sum_{m=-\infty}^{\infty}\sum_{n=0}^{\infty}\frac{nP_{m,n}}{mf_1+nf_2}=0$$

Note, there are very few assumptions involved in this derivation, and it can be applied to other non-linear devices (inductors, mechanical elements).

Also note that the Manley-Rowe power equations are:

- Independent of power level
- Independent of load impedance
- Independent of non-linear function
- Not limited to small-signal analysis

Measurement Techniques

The state (i.e. displacement) of the system was detected using a capacitive sensor via amplitude modulation techniques (carrier frequency = 100 kHz, bandwidth = 8.6 kHz).



All leads are coaxial/shielded from the pins of the differential amplifier to the pins of the packaged device to reduce parasitic capacitance/ambient effects.

Measurement Techniques

The noise floor of the circuit corresponds to ~0.9 nm, as calibrated by a Polytec OFV3001 Laser Vibrometer system.



The Laser system was also used to independently verify most measurements.

The Test Setup



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MEMS Fabrication

Silicon Dioxide



Silicon Substrate

Photoresist

Aluminum

1) Deposit mask oxide



4) Deep structural etch



6) Anisotropic floor etch



8) Isotropic release etch



5) Deposit conformal oxide







9) Metal sputter



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MEMS Design Components

We build our MEMS from a standard toolkit of components which serve particular functions.

The comb drive is a linear actuator, its force is not a function of the displacement

$$F(V) = \frac{n\varepsilon_0 V^2 h}{d}$$

The parallel plate drive is a nonlinear actuator

$$F(V) = \frac{1}{2} \varepsilon_0 h \ell \left(\frac{V}{d-x}\right)^2$$

The folded spring is a linear spring

F(x) = -kx







MEMS Design for paramp



Nonlinearity Characterization

Here, we see that applying a bias on the parallel plate drives does indeed serve to modify the behavior of the system.

Here, we demonstrate that the output amplitude depends on the impedance in the system (impedance is least at resonance, 5.91 kHz). The system is pumped by an 8V p-p signal at 5.6 kHz The input signal is ramped from 10 to 400 Hz at 8 V p-p

Here, we demonstrate that the gain depends on the impedance in the system (impedance is least at resonance, 5.91 kHz). This data is extracted from the previous plot (the same conditions apply)

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Here, we demonstrate that the gain observes the Manley-Rowe power relationship. That is, the gain is proportional to the ratio of frequencies

Pump at 5 kHz 10^{0} Signal ramped from 20 to 350 Hz Normalized Power Gain P_{-1,1}/P_{1,0} averaged over input amplitudes of 2.5 V to 10 V p-p 10⁻¹ Away from resonance Theoretical gain Pump = 8 VPump = 7 VPumb = 6 VPumb = 5 VPump = 4 V10⁻² 10² 10^{3} 10^{1} Frequency Ratio f_{-1,1}/f_{1,0}

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Here, we see that we can achieve very high gain with this device under the right conditions

Here, we see that we can achieve a linear response over a limited range

Pump at 10 kHz at 10⁻¹ Signal measured at 5 frequencies Power Gain P_{-1,1}/P_{1,0} 55.2632 Hz 128.9474 Hz 6316 Hz 276.3158 Hz 331.5789 Hz 10⁻⁴ 40 60 100 20 80 Input Power P_{1.0} (V²)

8 V p-p

Å) contact AFM MFM Cornell University

SCM

Scanning Force Microscopy

- There are several forces that occur in the atomic distances we are interested in:
- attractive electrostatic
- capillary (up to a few hundred Å)
- attractive van der Waals (a few Å to a few hundred Å) non-
- repulsive van der Waals (up to a few Å)
- chemical bonds (up to a few Å)
- magnetic

non-contact AFM

Force Gradient

All of the forces listed before are a function of tip/sample gap. This forms a force gradient.

If our mechanical system has a second-order behavior:

$$m\ddot{x} + c\dot{x} + k_{mechanical}x - F_{atomic}(x) = F_{excite}(V_e)$$

then the resonant frequency becomes:

$$f \propto \sqrt{\frac{1}{m} \left(k - \frac{\partial F_{atomic}(x)}{\partial x} \right)}$$

As long as the force gradient is of the same order of magnitude as the mechanical restoring force of the spring, then we will observe a frequency shift as the tip approaches the sample

MEMS Design for AFM

For experiments with a bias on the sample, we break the fuses and the sample and tip are no longer electrically connected

MEMS Design for AFM

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AFM Characterization

Here, we demonstrate that the resonant frequency depends on the distance between the tip and the sample.

The system is driven by a 5 V pseudo-random signal

The sample approach actuator is ramped from 16 to 19.5 V.

AFM Characterization

Here, we demonstrate that the output amplitude depends on the impedance in the system (same conditions apply as previous slide).

This trace shows the maximum amplitude at each step. This corresponds to the resonant frequency of the device at each step.

Effect of Bias on Force Gradient

Here, we see that a sample bias drastically affects the frequency response

Effect of Sample Composition

Here, we have deposited 40 nm of gold on top of the original aluminum tip

Comparison of Bias and Material

Here, we compare the change in frequency due to the addition of a bias and a change in the sample composition

Drive with pseudorandom signal from 500 HP89410A at 5 V 450 Tip Approach Voltage Squared (V²) 400 Note how gold 350 sample shifts more 300 as the tip/sample gap decreases 250 200 150 0 V on AI sample 100 0 V on Au sample 10 V on Al sample 10 V on Au sample 50 20 V on AI sample 20 V on Au sample 0 2200 2800 3000 3200 2400 2600 Frequency (Hz)

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Complete System Characterization

Here, we can see all of the harmonics generated

Note how the harmonics near the pump are largest amplitude

Complete System Characterization

We rotate the previous data to give a clearer view of the relative amplitudes

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Complete System Characterization

Clearer view of gain. This is a "cross-section" at a sample approach voltage of 10.8 V

XY Stage Schematic

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Conclusion

Parametric Amplifier Subsystem

Gain of 316.2
Linear amplification
Observes Manley-Rowe behavior

AFM Subsystem

Detects van der Waals forces (AFM)
Detects electrostatic forces (SCM)
Integrated sample

Complete System

Parametric amplifier mixes and amplifies results of AFM sensor
Maximum measured gain of 244
Fully integrated (no assembly or alignment)

Acknowledgements

This work would not be possible without the support of the following:

- Professor Noel MacDonald
- The members of the MacDonald Research Group
- The CNF Staff
- Kionix Inc.
- DARPA